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Attorney Docket SEL 238



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Hiroki et al.)
Serial No.: 09/776,472)
Filed: February 2, 2001)
For: Thin Film Formation Apparatus And)
Method Of Manufacturing Self-Light-)
Emitting Device Using Thin Film)
Formation Apparatus)
Art Unit: 1762)
Examiner: M. Cleveland)
Commissioner for Patents
Washington, D.C. 20231

I hereby certify that this correspondence is being
deposited with the United States Postal Service as
first class mail in an envelope addressed to:
the Assistant Commissioner for Patents, Washington,
D.C. 20231 on December 26, 2002
(Date of Deposit)

Ronelle Hammarquist
Name of applicant, assignee, or Registered Rep.
Ronelle Hammarquist 12-26-02
Signature Date

Sir:

In response to the Office Action of September 25, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

6 (Amended). A method of manufacturing a self-light-emitting device, comprising the steps

B1 of:

filling a nozzle with an application liquid for forming an EL layer; and

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